

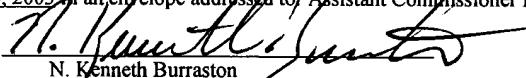


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9/24/03

PATENT
Docket No.: P276440-4

CERTIFICATE OF MAILING BY "FIRST CLASS MAIL" 37 C.F.R. §1.8

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail on April 14, 2003 in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231.


N. Kenneth Burraston

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In the application of: Eldridge et al.

Application No.: 09/781,833

Filing Date: February 12, 2001

For: Method For Forming Microelectronic Spring Structures On A Substrate

Examiner: A. Alanko

Group Art Unit: 1765

ELECTION/RESPONSE TO RESTRICTION REQUIREMENT

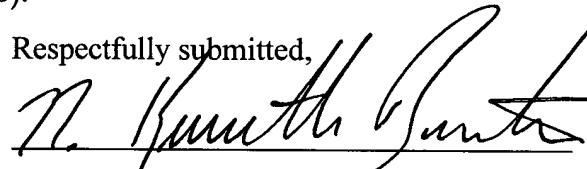
Assistant Commissioner of Patents

Washington, D.C. 20231

Sir:

In response to the Restriction Requirement dated January 14, 2003, the date for response to which has been extended to April 14, 2003 by the accompanying Petition For Extension Of Time, Applicants hereby elect without traverse the following species: 1-A (forming a molded surface in a sacrificial material), 2-E (photoresists), and 3-B (electrolytic plating). The following claims read on the elected species: claims 1-17, 19, 22-29, 40-52, and 56-67. Moreover, each of the foregoing claims is generic.

Although Applicants believe that all necessary extensions of time and fees have been provided for, Applicants request any extension of time required for acceptance of this paper, and Applicants authorize the Commissioner to charge any fee required for acceptance of this paper to Deposit Account No. 50-0285 (order no. P109-US).

Respectfully submitted,
By: 
N. Kenneth Burraston
Registration No. 39,923

Date: April 14, 2003

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